

[0021] As used herein, the term “operational mode” means a method or manner of functioning in a particular condition at a given time. For example, if a first electro-mechanical device is operating in a first resonant mode and a second electro-mechanical device is operating in a second resonant mode, the electro-mechanical transducer is operating collectively in, for example, a first operational mode. Alternatively, for example, if the first electro-mechanical device is operating in a third resonant mode, and the second electro-mechanical device is operating in a fourth resonant mode, the electro-mechanical transducer is operating collectively in a second operational mode. In another example, if the first electro-mechanical device is operating in a first resonant mode, and the second electro-mechanical device is not operating, the electro-mechanical transducer is operating collectively in a third operational mode. In other words, a given operation mode can be based on one electro-mechanical device operating in a resonant mode and another electro-mechanical device not being activated.

[0022] The term “resonant mode” means any mode of an electro-mechanical device operating in a frequency band centered around a resonant frequency. When an electro-mechanical device operates at or near a resonant frequency, several consequences occur. For example, when a transducer operates at or near a resonant frequency, the inertial term and the elastic terms substantially cancel. The power consumed by the actuator is then dedicated to balance dissipation (e.g. damping). If the dissipation is low, for example, in a cantilevered piezo-electric beam (i.e. a resonator with a high Q factor), the displacement is relatively large and limited by dissipative forces. In addition, if the mass that resonates is comparable to the mass of the structure to which the transducer is attached (e.g. case of a telephone), then the structure vibrates with a relatively large magnitude. Power lost during activation is in the dissipation. The remaining power is transmitted to the anatomy of the person with which the device is in contact.

[0023] The term “electro-mechanical device” as used herein, means an individual active component configured to provide haptic feedback. The term “active component” refers to a single component that provides a mechanical response to the application of an electrical signal. For example, for the embodiment illustrated in FIG. 5 and discussed below, a single length of, for example, piezoelectric material (for example, piezoelectric bar 410) and the associated mass (for example, mass 412) is referred to herein as the electro-mechanical device. In the example illustrated in FIG. 8 and discussed below, the electro-mechanical transducer includes only one electro-mechanical device.

[0024] The term “electro-mechanical transducer” means an apparatus having one or more electro-mechanical devices coupled to a mechanical ground. For example, in the illustrated in FIG. 5, the electro-mechanical transducer includes all three lengths of piezoelectric material, each having a mass coupled thereto. In the embodiment illustrated in FIG. 8, the electro-mechanical transducer includes piezoelectric bar 610 and the masses 620, 630, and 640.

[0025] An embodiment of an electro-mechanical transducer is illustrated in FIG. 1. An electro-mechanical transducer according to this embodiment includes a drive circuit 110 having an amplifier and includes an electro-mechanical transducer 120. The electro-mechanical transducer 120 includes one or more electro-mechanical (E-M) devices 121.

[0026] Drive 110 receives a haptic feedback signal and outputs a drive signal to electro-mechanical transducer 120. The haptic feedback signal may be based on a command from a microprocessor within, for example, a computer or a por-

table communications device (not shown). The electro-mechanical transducer 120 is configured to selectively operate in one of multiple possible operational modes at a given time. The operational mode of the electro-mechanical transducer 120 at a given time will depend, for example, on the characteristics of the drive signal received from driver 10. For a given operational mode, an electro-mechanical transducer can operate in multiple resonant modes as will be described in greater detail below. The one or more electro-mechanical devices 121 of electro-mechanical transducer 120 collectively output haptic feedback based on the drive signal, as illustrated in FIG. 7.

[0027] FIG. 2 illustrates a piezoelectric bar in accordance with one embodiment. As described below in more detail, such a piezoelectric bar can be used as an electro-mechanical device within an electro-mechanical transducer.

[0028] The piezoelectric bar 200 is a bimorph piezoelectric device that is a two-layer bending motor having a length (L) 220 substantially larger than a width (W) 210. In one embodiment, the piezoelectric bar 200 has a width (W) 210 of approximately 0.6 mm, a length (L) 220 of approximately 25 mm and a height (H) 230 of approximately 5 mm. Alternatively, the piezoelectric bar can have any suitable dimensions depending on the desired use.

[0029] When a voltage 240 from, for example, a drive source (not shown), is applied across the piezoelectric bar 200, the piezoelectric bar 200 will flex. An appropriate level of voltage 240 to be applied to the piezoelectric bar 200 can be selected, based at least in part, on the material and the thickness of the material used to construct the piezoelectric bar 200.

[0030] The piezoelectric bar 200 can be driven near a resonant frequency. When the piezoelectric bar 200 is driven near a resonant frequency, impedance transformation may be obtained. Impedance transformation results in large mechanical displacements as described above.

[0031] An electro-mechanical device 300 that can be used in combination with other electro-mechanical devices to construct an electro-mechanical transducer is illustrated as FIG. 3. Multiple electro-mechanical devices 300 can be configured to operate in a selected operational mode from a set of possible operational modes, each operational mode having one or more resonant modes, as will be described in further detail with respect to FIG. 5.

[0032] The electro-mechanical device 300 illustrated in FIG. 3 includes a piezoelectric bar 310 having mass 320 coupled to an end portion 325 of the piezoelectric bar 310. A second end portion 335 of the piezoelectric bar 310 is coupled to a base member 330. Base member 330 acts as a mechanical ground and is configured to remain stationary relative to the movement of the piezoelectric bar 310.

[0033] The electro-mechanical device illustrated in FIG. 3 can operate as follows. A voltage 340 from a voltage source (not shown) can be applied to piezoelectric bar 310. The piezoelectric bar can be, for example, a bimorph piezoelectric device as described above in connection with FIG. 2. Voltage 340 causes piezoelectric bar 310 to flex in a first direction  $D_1$ . Voltage 340 can be modulated at a frequency,  $f_d$ , which is referred to herein as the drive frequency of the electro-mechanical device 300. As described above, the frequency  $f_d$  can be selected such that the electro-mechanical device 300 operates near a resonant frequency the electro-mechanical device 300. Frequency  $f_d$  is a function of the type of electro-mechanical device used in the electro-mechanical transducer, the dimensions of the electro-mechanical device (e.g., the length, width, height or thickness), and the position and weight of the masses in the electro-mechanical device.